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PTO/SB/08A (10-96)

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Substitute for form 1449B/PTO		<b>Complete if Known</b>	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>		Application Number	10/538,769
		Filing Date	June 10, 2005
		First Named Inventor	BARTLETT, Philip Nigel
		Group Art Unit	<del>1742</del> 1795
(use as many sheets as necessary)		Examiner Name	Not Yet Assigned
Sheet	2	P-7916-US	2
		Attorney Docket Number	P-7916-US

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (where appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
	AF	International Search Report from PCT/GB 03/05442.	<input type="checkbox"/>
	AG	Nelson P.A., et al: "Mesoporous Nickel/Nickel Oxide Electrodes for High Power Applications," Journal of New Materials for Electrochemical Systems, Ecole Polytechnique de Montreal, Montreal, CA, vol.5, no. 1, January 2002 (2002-01), pages 63-65, XP001046009.	<input type="checkbox"/>
	AH	Nelson P.A., et al: "Mesoporous Nick/Nickel Oxide-A Nanoarchitected Electorode," Chemistry of Materials, American Chemical Society, Washington, US, vol. 14, no. 2, February 2002 (2002-02), pages 524-529, XP001163942.	<input type="checkbox"/>
	AI	Attard, G.S., et al: "Mesoporous Platinum Films from Lyotropic Liquid Crystalline Phases," Science, American Association for the Advancement of Science, US, vol. 278, 31 October 1997 (1997-10-31), pages 838-840, XP002071449.	<input type="checkbox"/>
	AJ	Attard, G.S., et al: " Mesoporous Pt/Ru Alloy from the Hexagonal Lyotropic Liquid Crystalline Phase of a Nonionic Sufactant," Chem. Material, 27 April 2001 (2001-04-27), pages 1444-1446, XP002306570.	<input type="checkbox"/>
	AK	Brown, I.J., et al: "Electrodeposition of Ni from a high internal phase Emulsion (HIPE) template," Electrochimica Acta, Elsevier Science Publishers, Barking, GB, vol. 46, no. 17, 15may 2001 (2001-05-15), pages 2711-2720, XP004239526.	<input type="checkbox"/>
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\* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Unique citation designation number. <sup>2</sup> Applicant is to place a check mark here if English language Translation is attached.

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